

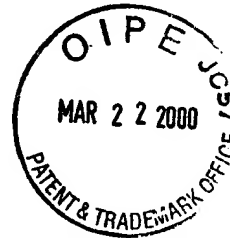
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yamazaki, et al Art Unit : 1753
Serial No.: 08/907,182 Examiner : A. Diamond
Filed : August 6, 1997
Title : THIN-FILM PHOTOELECTRIC CONVERSION DEVICE AND A
METHOD OF MANUFACTURING THE SAME

BOX AF

Assistant Commissioner for Patents
Washington, D.C. 20231

AMENDMENT



11/C
(W.M.)
3/24/00

In response to the Office Action mailed December 16, 1999,
kindly amend the above-referenced application as follows:

In the Claims:

Please cancel claims 31 and 56.

Please amend the following claims:

26. (Amended) A method of manufacturing a device
comprising:

providing a semiconductor film on an insulating surface
providing the semiconductor film with a catalyst [metal
containing] metal-containing material;

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I hereby certify under 37 CFR §1.8(a) that this
correspondence is being deposited with the
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